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## Origin and Reduction of 1/f Magnetic Flux Noise in Superconducting Devices

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Magnetic flux noise is a dominant source of dephasing and energy relaxation in superconducting qubits. The noise power spectral density varies with frequency as  $1/f^{\alpha}$  with  $\alpha \leq 1$  and spans 13 orders of magnitude. Recent work indicates that the noise is from unpaired magnetic defects on the surfaces of the superconducting devices. Here, we demonstrate that adsorbed molecular O<sub>2</sub> is the dominant contributor to magnetism in superconducting thin films. We show that this magnetism can be reduced by appropriate surface treatment or improvement in the sample vacuum environment. We observe a suppression of static spin susceptibility by more than an order of magnitude and a suppression of 1/f magnetic flux noise power spectral density of up to a factor of 5. These advances open the door to the realization of superconducting qubits with improved quantum coherence.

Low-frequency 1/f magnetic flux noise was first identified in the 1980s when Superconducting QUantum Interference Device (SQUID) circuits were cooled to millikelyin temperatures in an effort to reach quantumlimited sensitivity for applications such as gravity wave detection [1]. While the white noise level of these devices decreased as expected with decreasing temperature. an excess low-frequency flux noise persisted to the lowest temperatures. The flux noise power spectral density scaled with frequency as  $1/f^{\alpha}$  with  $\alpha \leq 1$ ; strangely, the magnitude of this excess noise was roughly independent of device geometry and materials [1]. At the time, many noise sources were ruled out; however, the microscopic origin of the noise was never identified. The source of flux noise has remained a longstanding puzzle in condensed matter physics [2].

More recently, it has been realized that this noise is a dominant source of dephasing in superconducting quantum bits ("qubits") [3–5], a leading candidate for scalable quantum information processing in the solid state [6–9]. In the context of a quantum annealer [10, 11], flux noise degrades performance by limiting the number of qubits that can tunnel coherently. For these reasons, there is strong motivation to understand and eliminate the flux noise.

Recent experiments indicate that there is a high density of unpaired surface spins in superconducting integrated circuits [12] and it is now believed that fluctuations of these spins give rise to the 1/f flux noise [13–15]. There is experimental evidence that interactions between the surface spins are significant [16]. To date, however, there has been no experimental data pointing toward the microscopic nature of the surface magnetic defects, although there has been speculation that the defects are due to localized states at the disordered metal-insulator interface [17] or to surface adsorbates [18], in particular molecular  $O_2$  [14].

Here we describe Xray Absorption Spectroscopy (XAS) and Xray Magnetic Circular Dichroism (XMCD) experiments that point to adsorbed molecular  $O_2$  as the dominant source of surface magnetism in superconducting thin films. We show that improvement in the vacuum environment of the superconducting sample and appropriate surface passivation can dramatically reduce the surface density of spins in superconducting thin films. We present data on the surface spin susceptibility and magnetic flux noise of devices before and after various surface treatments and demonstrate a significant suppression of magnetic activity and flux noise power. Our results rule out prevailing theoretical models that invoke localized defects at the metal-insulator interface [17] that interact via the RKKY mechanism [13]. Moreover, the implication of an extrinsic noise source provides a natural explanation for the observed weak dependence of the noise on device materials [1]. The achieved noise reduction opens the door to development of improved qubits with extended coherence times.

Using the Advanced Photon Source (APS) at Argonne National Laboratory, we have performed XAS and XMCD experiments on aluminum and niobium thin film samples. In XMCD, one monitors the absorption of a spin-polarized sample at specific Xray edges; the Xray energy provides elemental specificity, while the Xray helicity provides access to orbital magnetism. Devices were cooled to 10 K, and XMCD experiments were performed in fields up to 5 T. Initially we examined sputtered Al and Nb films cooled in ultrahigh vacuum (UHV;  $P \leq 10^{-9}$  Torr); we expect these films to be covered by an amorphous native oxide due to prolonged exposure to atmo-

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FIG. 1. (a) Xray magnetic circular dichroism (XMCD) at the oxygen K-edge for a native Al film and an Al film exposed to air. The native film (top) shows no XMCD signal, while the air-exposed film (bottom) shows a clear XMCD signal at 531 eV (traces are offset for clarity). A similar XMCD signal at the oxygen K-edge is seen for Nb films exposed to air (not shown). (b) Oxygen K-edge Xray absorption spectroscopy (XAS) of an Al thin film cooled in the presence of  $5 \times 10^{-8}$  Torr O<sub>2</sub>. Beginning around 45 K we observe a sharp peak at 531 eV and a broad spectral feature from 535-550 eV which we ascribe to adsorbed molecular O<sub>2</sub>. (Traces are offset for clarity). Dashed lines are from DFT simulations for Al<sub>2</sub>O<sub>3</sub> (XAS at 50 K) and for O<sub>2</sub>/Al<sub>2</sub>O<sub>3</sub> (XMCD and XAS at 10 K); see Supplement [19] for details.

sphere. We examined the Al and O K-edges in the Al films and the Nb L-edge and O K-edge in the Nb films and observed no XMCD signal at any of these energies [Fig. 1(a), upper trace]. However, when we intentionally degraded the vacuum of the sample cryostat by bleeding in air or dry  $O_2$  gas at a pressure of order  $10^{-6}$  Torr for several minutes, we observed a clear XMCD signal at the O K-edge [Fig. 1(a), lower trace]. Density functional theory (DFT) modeling allows us to assign the measured XMCD signal to molecular  $O_2$  [dashed line in Fig. 1(a)]. In a separate series of experiments, we ex-

posed the metal thin film continuously to oxygen as we cooled down from room temperature in an  $O_2$  partial pressure of  $5 \times 10^{-8}$  Torr; the experimental data and corresponding DFT calculations are shown in Fig. 1(b). We observe a strong modification of the O K-edge XAS signal starting at a temperature around 45 K, indicating the onset of significant adsorption. By comparing the spectral weight of the broad feature from 535-550 eVin the high-temperature spectra to that of the narrow peak at 531 eV in the low-temperature spectra, we can roughly quantify the amount of adsorbed oxygen relative to that bound in the native oxide of the metal. We conclude that the films are covered by 1-2 monolayers of adsorbed  $O_2$ . The best agreement between DFT and the measured XMCD and XAS signals occurs when the  $O_2$ bond is tilted with respect to the beam direction. This is consistent with prior DFT calculations of  $O_2$  adsorbed on  $Al_2O_3$  (0001), which indicate that the molecular bond axis is tilted at  $55^{\circ}$  from the surface normal [14].

The XMCD results suggest that the dominant magnetism in Al and Nb thin films of the type used to make qubit circuits is due not to a high density of intrinsic defects, but rather to adsorbed molecular  $O_2$ . The outermost electrons of the  $O_2$  molecule form a spin 1 triplet state [14].  $O_2$  is paramagnetic at high temperature; at low temperature, solid molecular  $O_2$  displays a complex phase diagram with multiple competing magnetic orders [20]. In typical superconducting qubit experiments, devices are cooled to millikelvin temperatures in vacuum cryostats that achieve pressures of order  $10^{-6}$  Torr prior to cooldown; this pressure corresponds to an adsorption rate of roughly 1 ML/s, assuming a unit sticking coefficient. Even when the cryostat is cold, there will be a continual flux of molecules from hot regions of the cryostat to cold regions where the sample is housed. Thus, an accumulation of magnetic  $O_2$  on the surface of these devices is inevitable.

This realization motivated us to attempt noise reduction by improving the vacuum environment of the superconducting devices. To this end, we have designed hermetic sample enclosures based on grade 5 titanium alloy (Ti-6Al-4V); see Fig. 2. This alloy has excellent UHV properties due to its low outgassing and its hardness, allowing realization of all-metal conflat seals. Moreover, the material is compatible with high-bandwidth weld-in hermetic SMA connectors. Finally, grade 5 titanium superconducts around 4.5 K, providing a magnetic shield for sensitive superconducting devices.

In Fig. 2 we show the details of the enclosure and the sample prep chamber. The sample box is pumped through a copper pinch tube with a turbomolecular pump and an ion pump. During evacuation, the sample enclosure and chamber are baked to  $120^{\circ}$ C. Following vacuum bake, the sample cell is cooled to room temperature and the cell is hermetically sealed using a commercial pinch tool. In some cases, the sample cell was backfilled with NH<sub>3</sub> gas prior to pinchoff. In other cases, the sample was irradiated with UV light (365 nm) during evacuation



FIG. 2. (a) Schematic of hermetic grade 5 titanium enclosure for susceptibility and flux noise measurements. The enclosure incorporates weld-in SMA feedthroughs and a single 2.75" conflat gasket. (b) Schematic of the sample prep chamber. The chamber incorporates a turbo pump, an ion pump, and a transfer arm used to install the NEG in the sample chamber following activation.

to promote photodesorption of strongly bound magnetic species, and a nonevaporable getter (NEG) pill (SAES Inc.) was activated in a separate chamber and transferred into the sample enclosure under vacuum. The NEG provides continuous pumping in the sample cell following pinchoff.

In a first series of experiments, we characterized the surface spin density on washer-style Nb SQUIDs by monitoring the temperature-dependent zero-frequency surface spin susceptibility of field-cooled devices, after the method described in [12]. The device layout is shown in the inset of Fig. 3. Here, we intentionally trap flux vortices in the thin films of the Nb SQUID by cooling through the superconducting transition in the presence of an applied magnetic field. Any unpaired magnetic defects on the surface of the device develop a thermal polarization in the relatively strong (tens of mT) local fields in the vortex core. As temperature decreases, the thermal polarization of the defect spins increases. The flux through the SQUID loop thus displays a roughly 1/TCurie-like dependence on temperature, and the measured flux change can be used to extract a surface density of unpaired spins. For typical devices, we infer a surface spin density of order  $10^{17}$  m<sup>-2</sup> [12, 21].

In Fig. 3 we compare baseline data to data from a cell that was evacuated and then backfilled with  $NH_3$  gas at approximately 100 Torr prior to pinchoff. The temperature-dependent flux is suppressed by roughly an order of magnitude. Nonmagnetic  $NH_3$  has a higher free energy of adsorption than  $O_2$  (1.5 eV versus 0.15 eV according to our DFT calculations on  $Al_2O_3$ ), and hence occupies available surface sites that would otherwise be taken up by magnetic  $O_2$ , resulting in a suppression of the surface density of adsorbed spins; related approaches to suppressing magnetic adsorbates were suggested in [14, 18].

Both susceptibility and magnetization noise scale linearly with spin density, and reduction in the density of surface spins should yield a reduction in flux noise power. In a final series of experiments, we have examined the flux noise of Al-based SQUIDs subjected to various surface



FIG. 3. Suppression of magnetic susceptibility. Temperaturedependent flux threading a square-washer Nb SQUID (350 pH; see inset) cooled in a conventional vacuum environment (closed red symbols) and cooled following vacuum bake and NH<sub>3</sub> passivation (blue open symbols). The arbitrary vertical offset on these curves has been adjusted so that all traces match at a temperature of 500 mK. The upper (lower) branches correspond to cooling fields of +128  $\mu$ T (-128  $\mu$ T). The magnitude of the flux change is proportional to the density of magnetically active surface spins [12].

treatments; the results are presented in Fig. 4 and Table I [22]. In these experiments, the Al-based first-stage device under test (DUT) is biased with a voltage, and the fluctuating current through the DUT is measured with a second Nb-based SQUID; measurements are performed in an adiabatic demagnetization refrigerator (ADR) at a temperature of 100 mK. We have characterized devices where the SQUID loop is encapsulated either in  $SiN_x$  or  $SiO_x$  grown by plasma enhanced chemical vapor deposition (PECVD). The SQUIDs described here were designed with a relatively high loop aspect ratio (ratio of loop width to trace width) of 25, as this geometry enhances the coupling of surface spin fluctuations to the device [5, 15, 23] (see Supplement [19]). We fit the measured noise spectra to the form  $A/f^{\alpha} + B$ , and we compare the 1/f noise power A and noise exponent  $\alpha$  measured on identical devices before and after surface treatment. In all, we have examined before/after spectra of 10 devices.

In the case of SQUIDs encapsulated in  $SiN_x$ , we observe a significant noise reduction both for devices passivated with NH<sub>3</sub> and for devices cooled in improved vacuum following UV illumination. Fig. 4a shows before/after spectra from one sample that was baked in the titanium cell and passivated with NH<sub>3</sub> using the protocol described above. The flux noise power spectral density at 1 Hz decreases from  $8.2 \ \mu \Phi_0^2/\text{Hz}$  to  $1.6 \ \mu \Phi_0^2/\text{Hz}$ . In Fig. 4b we show before/after spectra from a device that was subjected to UV illumination and cooled in improved vac-



FIG. 4. (a) Flux noise spectra of SQUID device  $SiN_x$ -4 before (upper trace) and after (lower trace) vacuum bakeout and NH<sub>3</sub> passivation. Inset shows device layout. (b) Flux noise spectra of SQUID device  $SiN_x$ -6 before (upper trace) and after (lower trace) vacuum bakeout and UV illumination.

uum; here, the flux noise power spectral density at 1 Hz decreases from 1.7  $\mu \Phi_0^2/\text{Hz}$  to 0.35  $\mu \Phi_0^2/\text{Hz}$ . We have examined a total of 6  $SiN_x$ -encapsulated devices; the results are summarized in the Table. For these devices, we observe a magnetic flux noise level of  $3.9 \pm 2.2 \,\mu \Phi_0^2/\text{Hz}$ at 1 Hz prior to surface treatment, with noise exponent  $\alpha = 0.95 \pm 0.17$ . Following treatment, we find a noise level  $1.7 \pm 1.0 \,\mu \Phi_0^2/\text{Hz}$  at 1 Hz with noise exponent  $\alpha = 0.83 \pm 0.18$ . A noise reduction is seen in every  $SiN_x$  encapsulated device, with an average reduction in  $S_{\Phi}(1 \text{ Hz})$  by a factor of 2.8 and a maximum noise reduction by a factor of 5.1. We remark that repeated noise measurements on individual devices (even following thermal cycle to 300 K) show very small variation in the absence of surface modification (see Supplement [19]): the robustness of the noise spectrum to thermal cycling suggests that fixed disorder at the surface dictates how the  $O_2$  molecules are adsorbed, or alternatively that strongly bound magnetic species persist to high temperature, providing a noise "fingerprint" for each device. To our knowledge, the 1/f flux noise spectral densities measured in our surface-treated nitride devices are the lowest reported in the literature, when the noise is appropriately scaled by the device aspect ratio.

In the case of  $\text{SiO}_x$ -encapsulated devices subjected to UV irradiation under vacuum, no clear noise suppression is seen. We speculate that this is because the UV photon energy of 3.4 eV is large enough to break bonds in the encapsulating oxide, perhaps liberating additional oxygen and providing another path for magnetic contamination.

		Pre-treatment		Post-treatment	
Device	Treatment	$\begin{array}{c} S_{\Phi}(1 \text{ Hz}) \\ (\mu \Phi_0^2/\text{Hz}) \end{array}$	$\alpha$	$\begin{array}{c} S_{\Phi}(1 \text{ Hz}) \\ (\mu \Phi_0^2/\text{Hz}) \end{array}$	α
$\operatorname{SiN}_{x}$ -1	UHV	2.0	1.0	1.4	1.1
$\operatorname{SiN}_{x}$ -2	$\rm NH_3$	4.4	0.7	2.4	0.7
$\operatorname{SiN}_{x}$ -3	UHV,UV	2.8	1.0	1.3	0.9
$\mathrm{SiN}_x$ -4	$\rm NH_3$	8.2	1.2	1.6	1.1
	UHV, UV			4.2	0.8
$\mathrm{SiN}_x$ -5	$\rm NH_3$	4.1	0.8	1.7	0.7
	UHV, UV			1.1	0.6
$\mathrm{SiN}_x$ -6	$\rm NH_3$	1.7	1.0	1.1	0.9
	UHV, UV			0.35	0.6
$SiO_x-1$	UHV, UV	13.4	0.5	13.7	0.5
$SiO_x-2$	UHV, UV	6.5	1.0	2.5	0.9
$SiO_x-3$	UHV, UV	4.8	0.7	5.1	1.1
$SiO_x-4$	UHV, UV	3.0	0.8	5.4	0.8

TABLE I. Noise reduction by vacuum and surface treatment. The Table includes results of before/after measurements on six SQUIDs with  $SiN_x$  loop encapsulation ( $SiN_x$ -1...6) and four SQUIDs with  $SiO_x$  loop encapsulation ( $SiO_x$ -1...4). Relative uncertainties in flux noise power spectral density  $S_{\Phi}(1 \text{ Hz})$  and noise exponent  $\alpha$  are 10% and 25%, respectively, as determined from repeated measurements following thermal cycling (see Supplement [19]).

Our ability to reduce 1/f flux noise power by up to a factor of 5 indicates clearly that adsorbates are the dominant source of low-frequency flux noise in our devices. It is reasonable to ask why the noise reduction is not larger. It could be that the remaining noise is still dominated by residual adsorbates. We measure pressure in the  $10^{-9}$  Torr range at the ion pump, and pressure in the cell is likely an order of magnitude higher. Improvements in vacuum could lead to further noise reduction. Once again, the suppression of static spin susceptibility in the Nb SQUID described in Fig. 3 is larger than the noise reductions in Al-based devices described in Fig. 4 and Table I. This discrepancy suggests that the details of the disordered surface play a critical role in dictating the adsorption and/or fluctuation dynamics of the  $O_2$  moments. We do measure systematically higher flux noise in oxide-encapsulated devices, and we have seen an increase in the flux noise of the nitride-encapsulated devices over the course of several years prior to this investigation of surface treatments, presumably due to uncontrolled evolution of the disordered surface; see Supplement [19]. Alternatively, it could be that the residual noise is due to some other magnetic states that are immune to the surface treatments described here.

Our DFT calculations indicate that an O<sub>2</sub> molecule adsorbed on Al<sub>2</sub>O<sub>3</sub> (0001) sits atop Al atoms and has a spin of 1.8  $\mu_B$  that rotates almost freely in the plane perpendicular to the molecular axis (barrier to spin rotation ~ 10 mK) [14, 24–26]. 1/f noise results from a distribution of relaxation times [27] that can arise from spin-spin interactions. DFT finds that neighboring O<sub>2</sub> molecules on Al<sub>2</sub>O<sub>3</sub> have ferromagnetic exchange, and Monte Carlo simulations show that a distribution of ferromagnetic interactions produces 1/f noise consistent with experiment [14]. Surface disorder could change the magnitude and sign of these interactions, affecting the noise exponent  $\alpha$ ; these questions are the focus of ongoing research.

In summary, we find that adsorbed molecular  $O_2$  is a dominant source of magnetism in superconducting devices. The identification of an extrinsic noise source explains the weak dependence of 1/f flux noise on device materials and invalidates prevailing theories for the noise based on defects at the metal-insulator interface. Suitable surface passivation and improvements in the sample vacuum environment lead to significant reductions in the surface spin susceptibility and low-frequency flux noise power. These developments open the door to the development of frequency-tunable superconducting qubits with improved dephasing times.

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- F. C. Wellstood, C. Urbina, and J. Clarke, Low-frequency noise in dc superconducting quantum interference devices below 1 K, Appl. Phys. Lett. 50, 772 (1987).
- [2] M. B. Weissman, 1/f noise and other slow, nonexponential kinetics in condensed matter, Rev. Mod. Phys. 60, 537 (1988).
- [3] F. Yoshihara, K. Harrabi, A. O. Niskanen, Y. Nakamura, and J. S. Tsai, Decoherence of flux qubits due to 1/f flux noise, Phys. Rev. Lett. 97, 167001 (2006).
- [4] K. Kakuyanagi, T. Meno, S. Saito, H. Nakano, K. Semba, H. Takayanagi, F. Deppe, and A. Shnirman, Dephasing of a superconducting flux qubit, Phys. Rev. Lett. 98, 047004 (2007).
- [5] R. C. Bialczak, R. McDermott, M. Ansmann, M. Hofheinz, N. Katz, E. Lucero, M. Neeley, A. D. O'Connell, H. Wang, A. N. Cleland, and J. M. Martinis, 1/f flux noise in Josephson phase qubits, Phys. Rev. Lett. 99, 187006 (2007).
- [6] M. H. Devoret and J. M. Martinis, Implementing qubits with superconducting integrated circuits, Quant. Info. Proc. 3, 163 (2004).
- [7] J. Clarke and F. K. Wilhelm, Superconducting quantum bits, Nature 453, 1031 (2008).
- [8] J. Kelly, R. Barends, A. G. Fowler, A. Megrant, E. Jeffrey, T. C. White, D. Sank, J. Y. Mutus, B. Campbell, Y. Chen, Z. Chen, B. Chiaro, A. Dunsworth, I.-C. Hoi, C. Neill, P. J. J. O'Malley, C. Quintana, P. Roushan, A. Vainsencher, J. Wenner, A. N. Cleland, and J. M. Martinis, State preservation by repetitive error detection in a superconducting quantum circuit, Nature **519**, 66 (2015).
- [9] A. D. Córcoles, E. Magesan, S. J. Srinivasan, A. W. Cross, M. Steffen, J. M. Gambetta, and J. M. Chow, Demonstration of a quantum error detection code using a square lattice of four superconducting qubits, Nat. Commun. 6, 6979 (2015).

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- [10] M. W. Johnson, M. H. S. Amin, S. Gildert, T. Lanting, F. Hamze, N. Dickson, R. Harris, A. J. Berkley, J. Johansson, P. Bunyk, E. M. Chapple, C. Enderud, J. P. Hilton, K. Karimi, E. Ladizinsky, N. Ladizinsky, T. Oh, I. Perminov, C. Rich, M. C. Thom, E. Tolkacheva, C. J. S. Truncik, S. Uchaikin, J. Wang, B. Wilson, and G. Rose, Quantum annealing with manufactured spins, Nature **473**, 194 (2011).
- [11] S. Boxio, V. N. Smelyanskiy, A. Shabani, S. V. Isakov, M. Dykman, V. S. Denchev, M. H. Amin, A. Yu. Smirnov, M. Mohseni, and H. Neven, Computational multiqubit tunnelling in programmable quantum annealers, Nat. Commun. 7, 10327 (2016).
- [12] S. Sendelbach, D. Hover, A. Kittel, M. Mück, J. M. Martinis, and R. McDermott, Magnetism in SQUIDs at millikelvin temperatures, Phys. Rev. Lett. **100**, 227006 (2008).
- [13] L. Faoro and L. B. Ioffe, Microscopic origin of lowfrequency flux noise in Josephson circuits, Phys. Rev. Lett. 100, 227005 (2008).
- [14] H. Wang, C. Shi, J. Hu, S. Han, C. C. Yu, and R. Q. Wu, Candidate source of flux noise in SQUIDs: Adsorbed oxygen molecules, Phys. Rev. Lett. **115**, 077002 (2015).
- [15] S. LaForest and R. de Sousa, Flux-vector model of spin noise in superconducting circuits: Electron versus nuclear spins and role of phase transition, Phys. Rev. B 92, 054502 (2015).
- [16] S. Sendelbach, D. Hover, M. Mück, and R. McDermott, Complex inductance, excess noise, and surface magnetism in dc SQUIDs, Phys. Rev. Lett. 103, 117001 (2009).
- [17] S. K. Choi, D.-H. Lee, S. G. Louie, and J. Clarke, Localization of metal-induced gap states at the metal-insulator interface: Origin of flux noise in SQUIDs and superconducting qubits, Phys. Rev. Lett. **103**, 197001 (2009).

- [18] D. Lee, J. L. DuBois, and V. Lordi, Identification of the local sources of paramagnetic noise in superconducting qubit devices fabricated on Al<sub>2</sub>O<sub>3</sub> substrates using density-functional calculations, Phys. Rev. Lett. **112**, 017001 (2014).
- [19] See Supplemental Material at [] for further details on DFT calculations, Xray data, and flux noise measurements.
- [20] Yu. A. Freiman and H. J. Jodl, Solid oxygen, Phys. Rep. 401, 1 (2004).
- [21] R. H. Koch, D. P. DiVincenzo, and J. Clarke, Model for 1/f flux noise in SQUIDs and qubits, Phys. Rev. Lett. 98, 267003 (2007).
- [22] The design of our Nb-based SQUIDs is not amenable to the study of flux noise. Conversely, the measurement of surface spin susceptibility requires us to controllably trap flux vortices in the thin films of our devices [12]. While this is possible in our Nb-based SQUIDs, we have been unable to do this in our Al-based devices. See Supplement [19] for details.
- [23] S. M. Anton, J. S. Birenbaum, S. R. O'Kelley, V. Bolkhovsky, D. A. Braje, G. Fitch, M. Neeley, G. C. Hilton, H.-M. Cho, K. D. Irwin, F. C. Wellstood, W. D. Oliver, A. Shnirman, and J. Clarke, Magnetic flux noise in dc SQUIDs: Temperature and geometry dependence, Phys. Rev. Lett. **110**, 147002 (2013).
- [24] E. Wimmer, H. Krakauer, M. Weinert, and A. Freeman, Full-potential self-consistent linearized-augmentedplane-wave method for calculating the electronic structure of molecules and surfaces: O<sub>2</sub> molecule, Phys. Rev. B 24, 864 (1981).
- [25] J. P. Perdew, K. Burke, and M. Ernzerhof, Generalized gradient approximation made simple, Phys. Rev. Lett. 77, 3865 (1996).
- [26] R. Q. Wu and A. Freeman, Effects of spin-orbit coupling in thin film magnetism, J. Magn. Magn. Mater. 200, 498 (1999).
- [27] P. Dutta and P. M. Horn, Low-frequency fluctuations in solids: 1/f noise, Rev. Mod. Phys. 53, 497 (1981).